

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,291,921
APPLICATION NO. : 10/810,660
ISSUE DATE : November 6, 2007
INVENTOR(S) : Wen-Jian Lin

Page 1 of 2

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On Page 5, Col. 1, line 1, Under Other Publications, delete "Survace" and insert - - Surface - -, therefor.

On Page 5, Col. 1, line 2, Under Other Publications, delete "Micromachined" and insert - - Micromachined - -, therefor.

On Page 5, Col. 1, line 4, Under Other Publications, delete "Lauderale" and insert - - Lauderdale - -, therefor.

On Page 5, Col. 1, line 6, Under Other Publications, delete "micromachine" and insert - - micromachined - -, therefor.

On Page 5, Col. 1, line 14, Under Other Publications, delete "Quanum" and insert - - Quantum - -, therefor.

On Page 5, Col. 1, line 34, Under Other Publications, delete "XeF2" and insert - - XeF₂ - -, therefor.

On Page 5, Col. 1, line 35, Under Other Publications, delete "SiO2" and insert - - SiO₂ - -, therefor.

On Page 5, Col. 2, line 58, Under Other Publications, delete "XeF2" and insert - - XeF₂ - -, therefor.

On Page 6, Col. 1, line 4, Under Other Publications, delete "Aluminoa" and insert - - Alumina - -, therefor.

On Page 6, Col. 1, line 11, Under Other Publications, delete "compatable" and insert - - compatible - -, therefor.

On Page 6, Col. 1, line 15, Under Other Publications, delete "vo" and insert - - vol. - -, therefor.

On Page 6, Col. 1, line 17, Under Other Publications, delete ""Maniature" and insert - - "Miniature - -, therefor.

On Page 6, Col. 1, line 20, Under Other Publications, delete "Internatioal" and insert - - International - -.

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therefor.

On Page 6, Col. 1, line 20, Under Other Publications, delete "Andactuators," and insert - - And Actuators, - -, therefor.

On Page 6, Col. 1, line 21, Under Other Publications, delete "Youk" and insert - - York - -, therefor.

On Page 6, Col. 1, line 26, Under Other Publications, delete "Review," and insert - - Review: - -, therefor.

On Page 6, Col. 2, line 18, Under Other Publications, delete "microelectomechanical systesm" and insert - - microelectromechanical systems - -, therefor.

On Page 6, Col. 2, line 19, Under Other Publications, delete "Comparision" and insert - - Comparison - -, therefor.

On Page 6, Col. 2, line 26, Under Other Publications, delete "Production" and insert - - Product - -, therefor.

In Col. 9, line 61, in Claim 1, after "layer" insert - - directly contacting the first material layer and - -.

In Col. 12, line 21 (approx.), in Claim 28, after "layer" insert - - directly contacting the material layer and - -.

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